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SERIAL NUMBER 10/633,576	FILING DATE 08/05/2003  RULE	CLASS 257 438	GROUP ART UNIT 2811	ATTORNEY DOCKET NO. 57454-963	
APPLICANTS  Hiroshi Maeda, Hyogo, JAPAN;  Toshiyuki Oashi, Hyogo, JAPAN; Takashi Uehara, Osaka, JAPAN;  ** CONTINUING DATA ***** This application is a DIV of 09/903,735 07/13/2001 PAT 6,630,705 YES TI  ** FOREIGN APPLICATIONS ***** JAPAN 2000-242303(P) 08/10/2000 YES TI  IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/30/2003					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>TI</i>		STATE OR COUNTRY JAPAN	SHEETS DRAWING 9	TOTAL CLAIMS 5	INDEPENDENT CLAIMS 1
ADDRESS McDermott, Will & Emery 600 13th Street, N.W. Washington, DC 20005-3096					
TITLE <i>Method of manufacturing a semiconductor device with capacitor electrodes</i> <i>Semiconductor device with capacitor electrodes and method of manufacturing thereof</i>					
FILING FEE  RECEIVED 750	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		